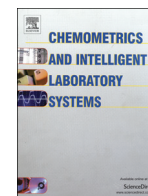




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A fault detection and diagnosis technique for multivariate processes using a PLS-decomposition of the measurement space

Q13 José L. Godoy^{a,b,*}, Jorge R. Vega^{a,c}, Jacinto L. Marchetti^a

^a INTEC (CONICET and Universidad Nacional del Litoral), Güemes 3450, (3000) Santa Fe, Argentina

^b FRP-UTN (Facultad Regional Paraná – Universidad Tecnológica Nacional), Almafuerte 1033 - (3100) Paraná, Argentina

^c FRSF-UTN (Facultad Regional Santa Fe – Universidad Tecnológica Nacional), Lavaisse 610, (3000) Santa Fe, Argentina

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ABSTRACT

A new statistical monitoring technique based on partial least squares (PLS) is proposed for fault detection and diagnosis in multivariate processes that exhibit collinear measurements. A typical PLS regression (PLSR) modeling strategy is first extended by adding the projections of the model outputs to the latent space. Then, a PLS-decomposition of the measurements into four terms that belongs to four different subspaces is derived. In order to online monitor the PLS-projections in each subspace, new specific statistics with non-overlapped domains are combined into a single index able to detect process anomalies. To reach a complete diagnosis, a further decomposition of each statistic was defined as a sum of variable contributions. By adequately processing all this information, the technique is able to: i) detect an anomaly through a single combined index, ii) diagnose the anomaly class from the observed pattern of the four component statistics with respect to their respective confidence intervals, and iii) identify the disturbed variables based on the analysis of the main variable contributions to each of the four subspaces. The effectiveness observed in the simulated examples suggests the potential application of this technique to real production systems.

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1. Introduction

Statistical process monitoring (SPM) applies multivariate statistics and machine learning methods to product quality and production control, fault detection and diagnosis, and estimation of fault/fault-free magnitudes. The SPM approaches based on historical operating data are useful when applied to process having a large number of measured variables and when causal models are unavailable [1]. In particular, latent variable (LV) models are more adequate than causal models to deal with monitoring tasks. Along the last two decades, several strategies based on LV models have been proposed for multivariate SPM [2–7]. When a process operates under normal conditions (i.e., when only ‘common-cause’ variations are present), then the correlation structure underlying the measured data can be adequately described through LV models. Monitoring techniques based on LV are useful for detecting and diagnosing abnormal behaviors in complex multivariate processes; and therefore they are of great interest for their use in industrial applications [8]. For instance, partial least squares (PLS) is often applied in Process Analytical Technology (PAT) projects, where most applications have successfully been used for monitoring biotechnological processes of the pharmaceutical industry [9].

Several fault detection indexes based on LV models can be used to alert on the presence of possible anomalies during the process operation. An alarm signal typically appears when an index exceeds its predefined control limit. Once a fault is detected, the fault diagnosis is made by analyzing the contributions of each measured variable to the specific index that caused the alarm. An essential requirement for fault diagnosis is to avoid misdiagnosis. For example, in the case of a fault in a sensor or in an actuator, only one variable associated to the faulty device should ideally contribute to the index with a high positive value. Contribution charts basically calculate the contributions of the variables in a fault situation and select the variables with large contributions as indicators of the probable cause of the fault [10]. Thus, an analysis of well-defined contributions should have the following desirable properties: i) in absence of faults, all contributions would exhibit similar low average values, thus determining a normal baseline level; ii) in the presence of a single fault (i.e., a fault that is due to only one variable), the contribution corresponding to the faulty variable should be large, and iii) in the presence of a multiple fault (e.g., multiple sensor failures), the abnormally large contribution of each faulty variable must be greater than the rest [11].

In medium and large scale processes (such as chemical manufacturing plants, food industries, etc.), there are a large number of controlled, manipulated, and process variables. When a multivariate process operates under normal conditions, then the measurement space spanned by the measured variables exhibits a non-full or deficient rank. In such a case, a model of the correlation structure among all

* Corresponding author at: INTEC (CONICET and Universidad Nacional del Litoral), Güemes 3450, (3000) Santa Fe, Argentina. Tel.: +54 342 4559175; fax: +54 342 4550944.

E-mail address: jlgodoy@santafe-conicet.gov.ar (J.L. Godoy).

measured variables is required for reaching a proper process monitoring. Methods of projection to LVs can be used to transform noisy collinear data into well-conditioned and reduced-dimension data that preserve all the useful information about the process, thus allowing the capture of the ‘common-cause’ subspace [7]. These data-driven methods typically use historic data (collected during normal operating conditions) to develop a LV model able to effectively explain the ‘common-cause’ variability. Several of these monitoring techniques (such as PCA: principal component analysis, ICA: independent component analysis, Kernel PCA, and Kernel ICA) treat the data without differentiating outputs from inputs [12–15]. In contrast, a PLS regression (PLSR) model is closer to the intrinsic structure of multi-input multi-output process [16,17], because it allows the elimination of some undesired input variables from the original pre-sets (e.g., those interfering the regression model) [18,19].

In the last years, several tools based on PLSR have been proposed for monitoring industrial processes [18,20–23]. Simultaneously, some efforts have also been aimed at improving the fundamentals of PLSR [24,25]. The development of surveillance PLSR tools able to detect anomalies or poor process performances is undoubtedly an active field of current research.

This article aims at developing an online data processing technique useful for helping process engineers to reach a swift identification of the origin of a fault when the monitoring system trigger an alarm signal. The paper is organized as follows. Section 2 describes the fundamentals of an extended PLSR modeling and their geometric properties, which was needed in order to obtain a new online PLS-decomposition of the measurements with associated statistics and contribution analysis. Section 3 presents the main statistical monitoring tools and describes their roles in the measurement PLS-decomposition. Section 4 discusses some simulation tests based on both static and dynamic systems. Finally, the main conclusions are presented in Section 5.

2. Extended PLSR modeling

The PLSR model developed here is calculated by simultaneously deflating the data matrices with the classical PLS–NIPALS algorithm [26]. This procedure gives better results for multivariate prediction and process monitoring than other alternative PLS algorithms [25]. Besides, the simultaneous deflation on both data matrices allows the detection of predictor variables playing an interfering effect [18].

Consider a process with m measured input variables plus p measured output variables. Assume that N measurements of each variable are collected while the process is operating under normal conditions. In order to build a model, the N multivariate measurements are arranged into a predictor matrix $\mathbf{X} = [\mathbf{x}_1 \dots \mathbf{x}_N]^T$ ($N \times m$) consisting of N samples of m variables per sample, and a response matrix $\mathbf{Y} = [\mathbf{y}_1 \dots \mathbf{y}_N]^T$ ($N \times p$), with N samples of p variables per sample. Then, PLSR can be used to find a regression model between the measurement vectors $\mathbf{x} = [x_1 \dots x_m]^T$ and $\mathbf{y} = [y_1 \dots y_p]^T$, even when their correlation matrices (\mathbf{R}_x and \mathbf{R}_y) are both positive semi-definite (i.e., \mathbf{X} and \mathbf{Y} have collinear variables). The method produces a projection of \mathbf{X} and \mathbf{Y} into low-dimension spaces defined by the number A of LV which are then regressed. At each iteration a , the implicit objective of the PLS–NIPALS algorithm (see Table 1) is to find a solution to the following optimization problem [25]:

$$\max_{\mathbf{w}_a, \mathbf{q}_a} (\mathbf{w}'_a \mathbf{X}'_a \mathbf{Y}_a \mathbf{q}_a) \quad \text{subject to: } \|\mathbf{w}_a\| = 1, \|\mathbf{q}_a\| = 1. \tag{1}$$

In Eq. (1), \mathbf{X}_a and \mathbf{Y}_a stand for the a -times deflated versions of $\mathbf{X}_1 = \mathbf{X}$ and $\mathbf{Y}_1 = \mathbf{Y}$ respectively. The number A of deflations to be made is determined by checking the residual matrices until the leftover information can no longer be modeled [18]. In this way, the PLSR modeling strategy produces an external and an internal model. The external

Table 1	t1.1
(X, Y)-deflated PLS–NIPALS algorithm. Outputs: P, Q, B, T, and U.	t1.2
Center the columns of X, Y to zero mean and scale them to unit variance.	t1.3
Set $a = 1, \mathbf{X}_1 = \mathbf{X}, \mathbf{Y}_1 = \mathbf{Y}$. (Initialization)	t1.4
1. Set \mathbf{t}_a^0 equal to the maximum-variance column of \mathbf{X}_a .	t1.5
Set \mathbf{u}_a equal to the maximum-variance column of \mathbf{Y}_a .	t1.6
2. $\mathbf{w}_a = \mathbf{X}'_a \mathbf{u}_a / \ \mathbf{X}'_a \mathbf{u}_a\ , (\ \mathbf{w}_a\ = 1)$.	t1.7
3. $\mathbf{t}_a = \mathbf{X}'_a \mathbf{w}_a$.	t1.8
4. $\mathbf{q}_a = \mathbf{Y}'_a \mathbf{t}_a / \ \mathbf{Y}'_a \mathbf{t}_a\ , (\ \mathbf{q}_a\ = 1)$.	t1.9
5. $\mathbf{u}_a = \mathbf{Y}'_a \mathbf{q}_a$.	t1.10
If $\ \mathbf{t}_a^0 - \mathbf{t}_a\ < \varepsilon$, go to step 6, else set $\mathbf{t}_a^0 = \mathbf{t}_a$ and return to step 2.	t1.11
6. $\mathbf{p}'_a = \mathbf{X}'_a \mathbf{t}_a / (\mathbf{t}'_a \mathbf{t}_a), \mathbf{p}_a = \mathbf{p}'_a / \ \mathbf{p}'_a\ , (\ \mathbf{p}_a\ = 1)$. #	t1.12
7. $\mathbf{t}_a = \mathbf{t}_a / \ \mathbf{p}'_a\ , \mathbf{w}_a = \mathbf{w}_a / \ \mathbf{p}'_a\ , (\ \mathbf{w}_a\ \neq 1)$. #	t1.13
8. $b_a = \mathbf{u}'_a \mathbf{t}_a / (\mathbf{t}'_a \mathbf{t}_a)$, (inner regression).	t1.14
9. $\mathbf{X}_{a+1} = \mathbf{X}_a - \mathbf{t}_a \mathbf{p}'_a, \mathbf{Y}_{a+1} = \mathbf{Y}_a - b_a \mathbf{t}_a \mathbf{q}'_a$, (deflations).	t1.15
10. $\mathbf{P} \leftarrow \mathbf{p}_a, \mathbf{Q} \leftarrow \mathbf{q}_a, \mathbf{B} \leftarrow b_a, \mathbf{T} \leftarrow \mathbf{t}_a, \mathbf{U} \leftarrow \mathbf{u}_a$, (save data to matrices).	t1.16
Set $a = a + 1$. If $a > A$, then stop; else return to step 1.	t1.17
# : Compensation of scales by previous normalization.	t1.18

model decomposes \mathbf{X} and \mathbf{Y} into score vectors (\mathbf{t}_a and \mathbf{u}_a), loading vectors (\mathbf{p}_a and \mathbf{q}_a), and residual error matrices ($\tilde{\mathbf{X}}$ and $\tilde{\mathbf{Y}}_2$), as follows:

$$\mathbf{X} = \sum_{a=1}^A \mathbf{t}_a \mathbf{p}'_a + \tilde{\mathbf{X}} = \mathbf{TP}' + \tilde{\mathbf{X}}, \quad \mathbf{P} = [\mathbf{p}_1 \dots \mathbf{p}_A], \tag{2}$$

$$\mathbf{Y} = \sum_{a=1}^A \mathbf{u}_a \mathbf{q}'_a + \tilde{\mathbf{Y}}_2 = \mathbf{UQ}' + \tilde{\mathbf{Y}}_2, \quad \mathbf{Q} = [\mathbf{q}_1 \dots \mathbf{q}_A], \tag{3}$$

where $\mathbf{T} = [\mathbf{t}_1 \dots \mathbf{t}_A]$ and $\mathbf{U} = [\mathbf{u}_1 \dots \mathbf{u}_A]$ are orthogonal by columns. In the internal model, \mathbf{t}_a is linearly regressed against the y -score vector \mathbf{u}_a , i.e.,

$$\mathbf{U} = \mathbf{TB} + \tilde{\mathbf{U}}, \quad \mathbf{B} = \text{diag}(b_1 \dots b_A) \tag{4}$$

where $b_1 \dots b_A$ are the regression coefficients determined by minimization of the residuals $\tilde{\mathbf{U}}$.

Call \mathbf{R} and \mathbf{S} the pseudo-inverses of \mathbf{P}' and \mathbf{Q}' , respectively (i.e., $\mathbf{P}'\mathbf{R} = \mathbf{I}$ and $\mathbf{Q}'\mathbf{S} = \mathbf{I}$). Then, for new \mathbf{X} and \mathbf{Y} , the predictions of \mathbf{T} and \mathbf{U} are directly obtained from Eqs. (2) and (3), as:

$$\mathbf{T} = \mathbf{XR}, \quad \mathbf{R} = [\mathbf{r}_1 \dots \mathbf{r}_A], \tag{5}$$

$$\mathbf{U} = \mathbf{YS}, \quad \mathbf{S} = [\mathbf{s}_1 \dots \mathbf{s}_A]. \tag{6}$$

Since the row space of $\tilde{\mathbf{X}}$ belongs to the null-space of \mathbf{R} , then $\tilde{\mathbf{X}}\mathbf{R} = \mathbf{0}$ [27]. Similarly for $\tilde{\mathbf{Y}}_2$, that belongs to the null space \mathbf{S} , and consequently $\tilde{\mathbf{Y}}_2\mathbf{S} = \mathbf{0}$. Hence, by combining Eqs. (3)–(5), the following prediction model is obtained:

$$\mathbf{Y} = \mathbf{XRBQ}' + \tilde{\mathbf{U}}\mathbf{Q}' + \tilde{\mathbf{Y}}_2 = \hat{\mathbf{Y}} + \tilde{\mathbf{Y}}_1 + \tilde{\mathbf{Y}}_2, \tag{7}$$

where $\tilde{\mathbf{Y}}_2 = \mathbf{Y} - \mathbf{YSQ}'$ and $\tilde{\mathbf{Y}}_1 = \mathbf{YSQ}' - \hat{\mathbf{Y}}$ are the projection and transformation error matrices, respectively. Hence, we have extended the PLSR model description by adding the projection of \mathbf{Y} to \mathbf{U} (Eq. (6)), which allows the decomposition of the prediction error $\tilde{\mathbf{Y}}$ into two terms: $\tilde{\mathbf{Y}}_1$ and $\tilde{\mathbf{Y}}_2$ (Eq. (7)).

2.1. PLS-decomposition of the input and output spaces

After synthesizing an ‘in-control’ PLSR model, the measurement vectors $\mathbf{x} \in \mathbb{R}^m$ and $\mathbf{y} \in \mathbb{R}^p$ can be decomposed as described below.

Lemma 1. Call $\Pi_{\mathbf{P}'\mathbf{R}}$ ($\Pi_{\mathbf{Q}'\mathbf{S}}$) the projector on the model subspace $S_{MX} \equiv \text{Span}\{\mathbf{P}'\} \subseteq \mathbb{R}^m$ ($S_{MY} \equiv \text{Span}\{\mathbf{Q}'\} \subseteq \mathbb{R}^p$), along the residual subspace $S_{RX} \equiv \text{Span}\{\mathbf{R}\}^\perp$ ($S_{RY} \equiv \text{Span}\{\mathbf{S}\}^\perp$). Then:

$$\Pi_{\mathbf{P}'\mathbf{R}} = \mathbf{PR}', \quad \Pi_{\mathbf{R}^\perp\mathbf{P}} = \mathbf{I} - \mathbf{PR}', \tag{8}$$

$$\Pi_{\mathbf{Q}'\mathbf{S}} = \mathbf{QS}', \quad \Pi_{\mathbf{S}^\perp\mathbf{Q}} = \mathbf{I} - \mathbf{QS}', \tag{9}$$

183 where $^\perp$ denotes the orthogonal complement of the subspace (see Proof 1 in
186 Appendix A).

187 From Lemma 1, we propose the following theorem on the PLS-
188 decomposition.

189 **Theorem 1.** The predictor and response vectors can be decomposed (by
190 PLSR) in complementary oblique projections as:

$$\begin{aligned} \mathbf{x} &= \hat{\mathbf{x}} + \tilde{\mathbf{x}} \in \mathbb{R}^m, \\ \hat{\mathbf{x}} &= \mathbf{P}\mathbf{R}'\mathbf{x} \in S_{MX} \equiv \text{Span}\{\mathbf{P}\}, \\ \tilde{\mathbf{x}} &= (\mathbf{I} - \mathbf{P}\mathbf{R}')\mathbf{x} \in S_{RX} \equiv \text{Span}\{\mathbf{R}\}^\perp \end{aligned} \quad (10)$$

$$\begin{aligned} \mathbf{y} &= \hat{\mathbf{y}} + \tilde{\mathbf{y}}_2 \in \mathbb{R}^p, \\ \hat{\mathbf{y}} &= \mathbf{Q}\mathbf{S}'\mathbf{y} \in S_{MY} \equiv \text{Span}\{\mathbf{Q}\}, \\ \tilde{\mathbf{y}}_2 &= (\mathbf{I} - \mathbf{Q}\mathbf{S}')\mathbf{y} \in S_{RY} \equiv \text{Span}\{\mathbf{S}\}^\perp, \end{aligned} \quad (11)$$

193 with the projections on the model subspaces S_{MX} and S_{MY} interrelated
195 according to:

$$\begin{aligned} \hat{\mathbf{y}}^* &= \hat{\mathbf{y}} + \tilde{\mathbf{y}}_1 \in S_{MY}, \\ \hat{\mathbf{y}} &= \mathbf{Q}\mathbf{B}\mathbf{R}'\hat{\mathbf{x}} \in S_{MY}, \\ \tilde{\mathbf{y}}_1 &= \mathbf{Q}\mathbf{S}'\mathbf{y} - \mathbf{Q}\mathbf{B}\mathbf{R}'\hat{\mathbf{x}} \in S_{MY}, \end{aligned} \quad (12)$$

196 where $\tilde{\mathbf{y}}_1$ is the error of the linear transformation $\hat{\mathbf{x}} \rightarrow \hat{\mathbf{y}}^*$, and $\hat{\mathbf{y}}$ denotes the
198 predictable part of $\hat{\mathbf{y}}^*$ from $\hat{\mathbf{x}}$ (see Proof 2 in Appendix A).

199 The minimum angle θ_x between the two complementary sub-
200 spaces S_{MX} and S_{RX} is defined as the number $0 \leq \theta_x \leq \pi/2$ that
201 satisfies: $\cos\theta_x = \max(\hat{\mathbf{x}}\tilde{\mathbf{x}}/\|\hat{\mathbf{x}}\|\|\tilde{\mathbf{x}}\|)$. A similar definition applies for
202 the minimum angle θ_y between S_{MY} and S_{RY} . In turn, θ_x (θ_y) can be es-
203 timated through [28]:

$$\sin\theta_x = 1/\|\mathbf{P}\mathbf{R}'\|_2, \quad \sin\theta_y = 1/\|\mathbf{Q}\mathbf{S}'\|_2 \quad (13)$$

204 The coordinates of $\hat{\mathbf{x}}$ and $\hat{\mathbf{y}}^*$ on the model subspaces S_{MX} and S_{MY} , are
206 given by:
207

$$\mathbf{t} = \mathbf{R}'\mathbf{x}, \quad \mathbf{u} = \mathbf{S}'\mathbf{y}, \quad (14a)$$

209 where $\mathbf{t} = [t_1 \dots t_A]'$ and $\mathbf{u} = [u_1 \dots u_A]'$. The latent vectors are related by:

$$\mathbf{u} = \mathbf{B}\mathbf{t} + \tilde{\mathbf{u}}, \quad (14b)$$

210 where $\tilde{\mathbf{u}} = \mathbf{B}\mathbf{t} = \mathbf{S}'\hat{\mathbf{y}}$ is the prediction of \mathbf{u} . Then, from Eqs. (10)–(12),
212 (14a) it results:

$$\hat{\mathbf{x}} = \mathbf{P}\mathbf{t}, \quad \hat{\mathbf{y}} = \mathbf{Q}\tilde{\mathbf{u}}. \quad (14c)$$

Therefore, the corresponding correlation matrices are related as
follows:

$$\mathbf{\Lambda} = \mathbf{R}'\mathbf{R}_x\mathbf{R} = (\mathbf{N} - 1)^{-1}\mathbf{T}'\mathbf{T} = \text{diag}(\lambda_1 \dots \lambda_A), \quad (15a)$$

$$\mathbf{\Delta} = (\mathbf{N} - 1)^{-1}\hat{\mathbf{U}}'\hat{\mathbf{U}} = \mathbf{B}\mathbf{\Lambda}\mathbf{B} = \text{diag}(\hat{\delta}_1 \dots \hat{\delta}_A), \quad (15b)$$

$$\mathbf{R}_{\hat{\mathbf{x}}} = (\mathbf{N} - 1)^{-1}\hat{\mathbf{X}}'\hat{\mathbf{X}} = \mathbf{P}\mathbf{\Lambda}\mathbf{P}' = \sum_{a=1}^A \lambda_a \mathbf{p}_a \mathbf{p}_a', \quad (15c)$$

$$\mathbf{R}_{\hat{\mathbf{y}}} = (\mathbf{N} - 1)^{-1}\hat{\mathbf{Y}}'\hat{\mathbf{Y}} = \mathbf{Q}\mathbf{\Delta}\mathbf{Q}' = \sum_{a=1}^A \lambda_a b_a^2 \mathbf{q}_a \mathbf{q}_a', \quad (15d)$$

where λ_i and $\hat{\delta}_i$ are the estimated variances of t_i and \hat{u}_i , respectively. 224

The main geometric properties of the PLS-decomposition are repre-
sented in Fig. 1 for an idealized low-order hypothetical system. Both
measurement vectors (\mathbf{x} and \mathbf{y}) are decomposed into their respective
projections; and the corresponding control regions (intervals for S_{RX}
and S_{RY} , and ellipses for S_{MX} and S_{MY}), are also indicated. The oblique
minimum angles θ_x (θ_y) between the model subspace S_{MX} (S_{MY}) and
the complementary residual subspace S_{RX} (S_{RY}) are easily visualized. 231

3. Process monitoring based on PLS-decomposition 232

The SPM includes three main activities: 1) the detection of an out-of-
control condition or occurrence of an anomaly; 2) the diagnostic achieved
by classifying the type of anomaly that has generated the abnormal be-
havior, and 3) the isolation of the disturbed variables and – ideally – of
the disturbing sources. In the following, every one of these points is
analyzed. 238

3.1. PLS-based fault detection 239

Once an in-control PLSR model is developed using process data
under normal operating conditions, the process state can be followed
by projecting the actual measurements \mathbf{x} and \mathbf{y} on subspaces S_{MX} , S_{RX} ,
 S_{MY} , and S_{RY} , and by using the proper statistics with its control limits.
For example, a signal of an unexpected change in the input variables \mathbf{x}
can be detected by using the \mathbf{t} -based Hotelling's T^2 statistic in S_{MX} , 245

$$T_{\mathbf{t}}^2 = \|\mathbf{\Lambda}^{-1/2}\mathbf{t}\|^2 = \|(\mathbf{\Lambda}^{-1/2}\mathbf{R}')\hat{\mathbf{x}}\|^2 = \|(\mathbf{\Lambda}^{-1/2}\mathbf{R}')\mathbf{x}\|^2, \quad (16)$$

which can be compared against a control limit. This statistic measures a
meaningful change on the model subspace S_{MX} , and serves for discrim-
inating excessive changes from normal variations. 248

However, when a special event that was not originally considered by
the PLSR model occurs, the new observations \mathbf{x} will partially move 251

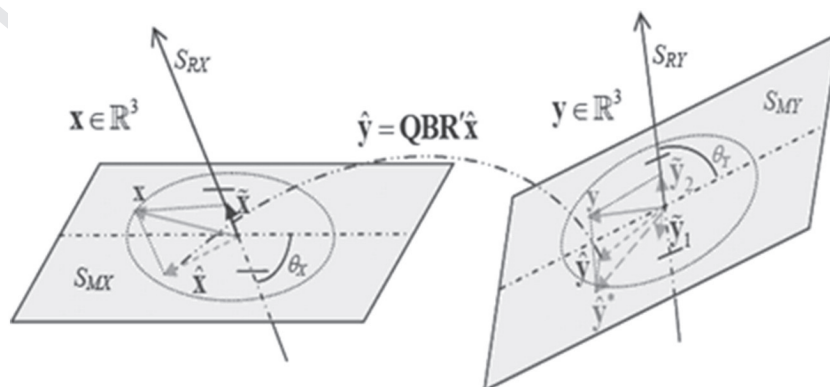


Fig. 1. Schematic representation of the PLS-decomposition of the measurement vectors \mathbf{x} and \mathbf{y} in their projections on the model and residue subspaces. The in-control regions are also indicated.

252 outside S_{MX} towards S_{RX} , showing an increment in the squared of the
253 predicted error $SPE_{\mathbf{x}}$,

$$SPE_{\mathbf{x}} = \|\tilde{\mathbf{x}}\|^2 = \|(\mathbf{I}-\mathbf{P}\mathbf{R}')\mathbf{x}\|^2. \quad (17)$$

254

256 This last statistic measures the distance to the model lying in S_{RX} ; in
257 other words, it shows a departure of \mathbf{x} from the regular expected behav-
258 ior by going to the subspace S_{RX} . Similarly, the $\hat{\mathbf{u}}$ -based Hotelling's T^2 sta-
259 tistic can be written as

$$T_{\hat{\mathbf{u}}}^2 = \|\Delta^{-1/2}\hat{\mathbf{u}}\|^2 = \|(\Delta^{-1/2}\mathbf{S}')\hat{\mathbf{y}}\|^2, \quad (18)$$

260 and used for detecting significant amplitude changes lying in the model
262 subspace S_{MY} . Also, the distance to the regression model in S_{MY} can be
263 written as [see Eqs. (12, 14)]:

$$SPE_{\mathbf{y}_1} = \|\tilde{\mathbf{y}}_1\|^2 = \left\| \begin{bmatrix} \mathbf{Q}\mathbf{S}' & -\mathbf{Q}\mathbf{B}\mathbf{R}' \end{bmatrix} \begin{bmatrix} \mathbf{y} \\ \mathbf{x} \end{bmatrix} \right\|^2 = \|\mathbf{Q}(\mathbf{S}'\mathbf{y}-\mathbf{B}\mathbf{R}'\mathbf{x})\|^2. \quad (19)$$

264

266 Similarly, the distance to the model lying in S_{RY} is defined as:

$$SPE_{\mathbf{y}_2} = \|\tilde{\mathbf{y}}_2\|^2 = \|(\mathbf{I}-\mathbf{Q}\mathbf{S}')\mathbf{y}\|^2. \quad (20)$$

268

269 Matrices $\mathbf{R}_{\hat{\mathbf{x}}}$ and $\mathbf{R}_{\hat{\mathbf{y}}}$ (Eqs. 15c, 15d) are often singular because $\hat{\mathbf{x}}$ and $\hat{\mathbf{y}}$
270 typically have collinear variables, as it is inferred from Eq. (14c). Conse-
271 quently, the generalized Mahalanobis distance of $\hat{\mathbf{x}}$ and $\hat{\mathbf{y}}$ can be used to
272 measure the projections as follows:

$$D_{\hat{\mathbf{x}}} = \hat{\mathbf{x}}' \mathbf{R}_{\hat{\mathbf{x}}}^{-1} \hat{\mathbf{x}}, \quad (21a)$$

273

$$D_{\hat{\mathbf{y}}} = \hat{\mathbf{y}}' \mathbf{R}_{\hat{\mathbf{y}}}^{-1} \hat{\mathbf{y}}. \quad (21b)$$

276

277 The following theorem states that not all these statistics are
278 independent.

279 **Theorem 2.** The Mahalanobis distances computed from $\hat{\mathbf{x}}$, \mathbf{t} , $\hat{\mathbf{u}}$, and $\hat{\mathbf{y}}$ are
280 equivalent, i.e., $D_{\hat{\mathbf{x}}} = T_{\hat{\mathbf{t}}}^2 = T_{\hat{\mathbf{u}}}^2 = D_{\hat{\mathbf{y}}}$ (see Proof 3 in Appendix A).

281 The identity in Theorem 2 suggests that the behavior of the response
282 variables \mathbf{y} can be monitored through the predictor variables \mathbf{x} . There-
283 fore, the monitoring of the complete measurement space can be
284 implemented through the following independent statistics: $T_{\hat{\mathbf{t}}}^2$, $SPE_{\mathbf{x}}$,
285 $SPE_{\mathbf{y}_1}$, and $SPE_{\mathbf{y}_2}$, each one actuating in a different subspace: S_{MX} , S_{RX} ,
286 S_{MY} , and S_{RY} , respectively (see Fig. 1). Consequently, a combined detec-
287 tion index I_{TC} can be defined to attain the whole measurement space
288 without signal superposition,

$$I_{TC} = \frac{T_{\hat{\mathbf{t}}}^2}{\tau_{\alpha}^2} + \frac{SPE_{\mathbf{x}}}{\delta_{\mathbf{x},\alpha}^2} + \frac{SPE_{\mathbf{y}_1}}{\delta_{\mathbf{y}_1,\alpha}^2} + \frac{SPE_{\mathbf{y}_2}}{\delta_{\mathbf{y}_2,\alpha}^2} = [\mathbf{y}' \ \mathbf{x}'] \Phi \begin{bmatrix} \mathbf{y} \\ \mathbf{x} \end{bmatrix}, \quad (22)$$

289 where τ_{α}^2 , $\delta_{\mathbf{x},\alpha}^2$, $\delta_{\mathbf{y}_1,\alpha}^2$, $\delta_{\mathbf{y}_2,\alpha}^2$ are the respective control limits with a
291 confidence level α , and Φ is a symmetric positive-definite matrix
292 ($\Phi > 0$). Note that in this way the significance level of each normal-
293 ized statistic is 1. The vector arrangement on the right of Eq. (22) is
294 derived from Eqs. (16, 17, 19, 20), and it shows that the resulting
295 quadratic index depends on the extended vector $[\mathbf{y}' \ \mathbf{x}']'$. As indicat-
296 ed in Appendix B, a control limit I_{α} (with a confidence level α) can
297 also be defined for I_{TC} ; and this index is useful for simultaneous mon-
298 itoring of product quality, process changes, and sensor problems.
299 This combined detection index defines a multidimensional elliptic
300 region that is compatible with the assumption of multi-normal
301 data. Therefore, the amount of false alarms and undetected faults
302 are significantly reduced with respect to the performance typically
303 yielded by separated indexes [12]. The main difference among the
304 statistics composing the combined index I_{TC} are the different scaling
305 factor and the subspace where they are relevant. Typically, the scale

τ_{α}^2 for the statistic $T_{\hat{\mathbf{t}}}^2$ is much larger than the scale factors $\delta_{\mathbf{x},\alpha}^2$, $\delta_{\mathbf{y}_1,\alpha}^2$,
306 or $\delta_{\mathbf{y}_2,\alpha}^2$ for the quadratic errors. This happens because the noise-like
307 variability of the errors are much smaller than the signal variability
308 of $T_{\hat{\mathbf{t}}}^2$ responding to the correlation structure. Thus, a multivariate
309 change in \mathbf{x} (from its normal values) that lies on S_{MX} produces a con-
310 tribution to I_{TC} that is lower than a change of similar magnitude on
311 S_{RX} , S_{MY} , or S_{RY} , measured by $SPE_{\mathbf{x}}$, $SPE_{\mathbf{y}_1}$, or $SPE_{\mathbf{y}_2}$, respectively.
312

3.2. Diagnosis of process anomalies

313

In order to determine the discriminating capacity of the four statis-
314 tics composing the index I_{TC} , an artificial process system – here identi-
315 fied with the subscript 0 – is created for generating ideal data obeying
316 to a predetermined correlation structure. This artificial process is def-
317 ined by first setting values to the PLSR matrices \mathbf{A}_0 , \mathbf{P}_0 , \mathbf{B}_0 , and \mathbf{Q}_0 ,
318 that stand for a model of the system behavior under normal condition.
319 In this procedure, the random score vector $\mathbf{t}_0 \in \mathbb{R}^A \sim N(\mathbf{0}, \mathbf{A}_0)$ works as
320 an independent variable to generate the associate vectors of “input”
321 and “output” responses by
322

$$\begin{aligned} \mathbf{x}_0 &= \mathbf{P}_0 \mathbf{t}_0 \in S_{MX} \equiv \text{Span}\{\mathbf{P}_0\} \subseteq \mathbb{R}^m, \\ \mathbf{y}_0 &= \mathbf{Q}_0 \mathbf{B}_0 \mathbf{t}_0 \in S_{MY} \equiv \text{Span}\{\mathbf{Q}_0\} \subseteq \mathbb{R}^p, \end{aligned} \quad (23)$$

323

325 Since Eq. (23) are linear combinations of random variables, the
326 resulting input and output vectors respectively follow: $\mathbf{x}_0 \sim N$
327 $(\mathbf{0}, \mathbf{P}_0 \mathbf{A}_0 \mathbf{P}_0')$ and $\mathbf{y}_0 \sim N(\mathbf{0}, \mathbf{Q}_0 \mathbf{B}_0 \mathbf{A}_0 \mathbf{B}_0 \mathbf{Q}_0')$, thus featuring ‘common-
328 cause’ variations only. Since these data stand for an ideal perfect
329 model, the residuals $\tilde{\mathbf{x}}$, $\tilde{\mathbf{y}}_1$ and $\tilde{\mathbf{y}}_2$ are null, and there are no differences
330 between model predictions and ideal data, i.e., $\hat{\mathbf{x}} = \mathbf{x}_0$ and $\hat{\mathbf{y}} = \mathbf{y}_0$.
331

332 An anomalous event is detected by a significant change in the mea-
333 surements, which triggers the alarm condition when $I_{TC} \geq I_{\alpha}$. The above
334 measurement decomposition allows the discrimination among six differ-
335 ent classes of anomaly sources, facilitating in this way the diagnostic task.
336 Each one of these six alternatives is analyzed by assuming that data are
337 generated under localized pure disturbances and then observing the de-
338 tection track followed with the available model (\mathbf{A}_0 , \mathbf{P}_0 , \mathbf{B}_0 , \mathbf{Q}_0). The sketch
339 in Fig. 2 helps to visualize how a warning signal (at $\tilde{\mathbf{x}}$, $\tilde{\mathbf{y}}_1$, $\tilde{\mathbf{y}}_2$ or \mathbf{t}) is
340 generated as the disturbed measurements (\mathbf{x} or \mathbf{y}) go through the PLSR
341 model.

342 Hence, under the above framework, the following classes of anoma-
343 lies are discriminated:

344 **Class 1.** Sensor faults associated to \mathbf{x} , represented by additional signals
345 ξ , that take the $\hat{\mathbf{x}}$ vector out of the pattern cast by the PLSR model. In this
346 case, the input vector can be written as,

$$\mathbf{x} = \mathbf{x}_0 + \xi, \quad (\text{Data generation})$$

347 where \mathbf{x}_0 is the “free-of-change” part of the input-vector measurement.
348 Let us assume that the disturbance ξ does not follow the correlation pat-
349 tern of \mathbf{x}_0 at all (see Eq. (23)), in other words, $\xi \in S_{RX}$. Then, $\mathbf{t} = \mathbf{R}'_0 \mathbf{x} =$
350 $\mathbf{R}'_0 \mathbf{x}_0 + \mathbf{R}'_0 \xi = \mathbf{t}_0 + 0 = \mathbf{t}_0$, which shows that the disturbance goes
351 completely to the residual variable

$$\tilde{\mathbf{x}} = \mathbf{x} - \hat{\mathbf{x}} = \mathbf{x} - \mathbf{P}_0 \mathbf{t} = \mathbf{x} - \mathbf{x}_0 = \xi \neq 0 \in S_{RX} (\text{Disturbance detection})$$

352

353 **Class 2.** Sensors faults associated to the output variable \mathbf{y} ,

354

$$\mathbf{y} = \mathbf{y}_0 + \eta, \quad (\text{Data generation})$$

355 where \mathbf{y}_0 is the “free-of-change” part with a population structure deter-
356 mined by the normal conditions only. This disturbance is analyzed by
357 assuming that $\eta \in S_{RY}$. Hence, the disturbance track from generation
358 to detection is as follows:
359

$$\hat{\mathbf{y}}^* = \mathbf{Q}_0 \mathbf{S}'_0 \mathbf{y} = \mathbf{Q}_0 \mathbf{S}'_0 \mathbf{y}_0 + \mathbf{Q}_0 \mathbf{S}'_0 \eta = \mathbf{y}_0 + 0 = \mathbf{y}_0,$$

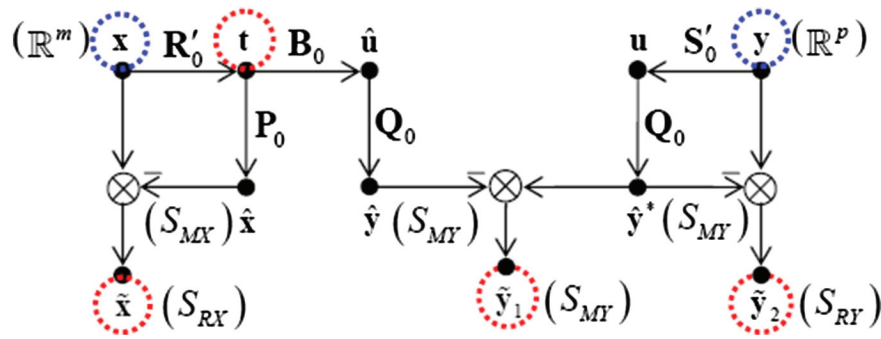


Fig. 2. Measurements decomposition based on projections onto the subspaces created by a PLSR model.

360 $\tilde{y}_2 = y - \hat{y}^* = \eta \neq 0 \in S_{RY}$, (Disturbance detection)

362 and again, a measurement disturbance not associable with the normal
364 behavior is sent to a residual subspace, in this case, S_{RY} .

365 **Class 3.** Changes in the correlation structure of \mathbf{x} . An \mathbf{x} vector popula-
366 tion affected by this kind of change can also be generated by the same
367 score \mathbf{t}_0 , but using an “unknown” change $\Delta\mathbf{P} = \mathbf{P} - \mathbf{P}_0$, i.e.,

$$\mathbf{x} = \mathbf{P}\mathbf{t}_0 = (\mathbf{P}_0 + \Delta\mathbf{P})\mathbf{t}_0 = \mathbf{x}_0 + \Delta\mathbf{P}\mathbf{t}_0. \quad (\text{Data generation})$$

368 It should be noted, however, that when using the measurement \mathbf{x}
370 with the available model \mathbf{P}_0 , the scores change to $\mathbf{t} = \mathbf{R}'_0\mathbf{x} = \mathbf{R}'_0(\mathbf{P}_0 + \Delta\mathbf{P})$
371 $\mathbf{t}_0 = \mathbf{t}_0 + \mathbf{R}'_0\Delta\mathbf{P}\mathbf{t}_0$, thus generating the following no-null residual values

$$\begin{aligned} \tilde{\mathbf{x}} &= \mathbf{x} - \hat{\mathbf{x}} = (\mathbf{x}_0 + \Delta\mathbf{P}\mathbf{t}_0) - \mathbf{P}_0\mathbf{t}_0 = (\mathbf{x}_0 + \Delta\mathbf{P}\mathbf{t}_0) - (\mathbf{x}_0 + \mathbf{P}_0\mathbf{R}'_0\Delta\mathbf{P}\mathbf{t}_0) \\ &= (\mathbf{I} - \mathbf{P}_0\mathbf{R}'_0)\Delta\mathbf{P}\mathbf{t}_0 \neq 0 \in S_{RX}, \tilde{\mathbf{y}}_1 = \hat{\mathbf{y}}^* - \hat{\mathbf{y}} = \mathbf{y}_0 - \mathbf{Q}_0\mathbf{B}_0\mathbf{t} \\ &= \mathbf{y}_0 - \mathbf{Q}_0\mathbf{B}_0(\mathbf{t}_0 + \mathbf{R}'_0\Delta\mathbf{P}\mathbf{t}_0) = -\mathbf{Q}_0\mathbf{B}_0\mathbf{R}'_0\Delta\mathbf{P}\mathbf{t}_0 \neq 0 \in S_{MY}. \end{aligned}$$

373 where the residues $\tilde{\mathbf{x}}$ and $\tilde{\mathbf{y}}_1$ are used to detect the disturbance. Also, it is
375 important to note that $\|\Lambda_0^{-1/2}\mathbf{R}'_0\tilde{\mathbf{x}}\|^2 / \tau_\alpha^2 \ll \|\tilde{\mathbf{x}}\|^2 / \delta_{x,\alpha}^2$ when $\|\tilde{\mathbf{x}}\|^2 = \|\tilde{\mathbf{x}}\|^2$.

376 **Class 4.** Changes in the intrinsic gains. The diagonal matrix \mathbf{B} is the
377 core place where the PLSR model ties up input with output vari-
378 ables. Let us assume an unknown change occurred in this matrix,
379 i.e.,

$$\hat{\mathbf{y}}^* = \mathbf{Q}_0\mathbf{B}\mathbf{t}_0 = \mathbf{Q}_0(\mathbf{B}_0 + \Delta\mathbf{B})\mathbf{t}_0 = \mathbf{y}_0 + \mathbf{Q}_0\Delta\mathbf{B}\mathbf{t}_0, \quad (\text{Data generation})$$

380 and analyze the effects on the statistics being considered for mon-
382 itoring,

$$\tilde{\mathbf{y}}_1 = \hat{\mathbf{y}}^* - \hat{\mathbf{y}} = (\mathbf{y}_0 + \mathbf{Q}_0\Delta\mathbf{B}\mathbf{t}_0) - \mathbf{Q}_0\mathbf{B}_0\mathbf{t}_0 = \mathbf{Q}_0\Delta\mathbf{B}\mathbf{t}_0 \neq 0 \in S_{MY}$$

383 which tells that the “detecting signal” should be observed by mon-
385 itoring the residue $\tilde{\mathbf{y}}_1$ on S_{MY} , while the remaining statistics remain
386 unaffected (see Fig. 2).

387 **Class 5.** Changes in the correlation structure of \mathbf{y} . Let us assume an un-
388 known change in the matrix \mathbf{Q} , i.e.

$$\mathbf{y} = \mathbf{Q}\mathbf{B}_0\mathbf{t}_0 = (\mathbf{Q}_0 + \Delta\mathbf{Q})\mathbf{B}_0\mathbf{t}_0 = \mathbf{y}_0 + \Delta\mathbf{Q}\mathbf{B}_0\mathbf{t}_0 \quad (\text{Data generation})$$

389 and the detection track characterized by

$$\begin{aligned} \hat{\mathbf{y}}^* &= \mathbf{Q}_0\mathbf{S}'_0\mathbf{y} = \mathbf{Q}_0\mathbf{S}'_0(\mathbf{y}_0 + \Delta\mathbf{Q}\mathbf{B}_0\mathbf{t}_0) = \mathbf{y}_0 + \mathbf{Q}_0\mathbf{S}'_0\Delta\mathbf{Q}\mathbf{B}_0\mathbf{t}_0\tilde{\mathbf{y}}_2 = \mathbf{y} - \tilde{\mathbf{y}}^* \\ &= (\mathbf{y}_0 + \Delta\mathbf{Q}\mathbf{B}_0\mathbf{t}_0) - (\mathbf{y}_0 + \mathbf{Q}_0\mathbf{S}'_0\Delta\mathbf{Q}\mathbf{B}_0\mathbf{t}_0) \\ &= (\mathbf{I} - \mathbf{Q}_0\mathbf{S}'_0)\Delta\mathbf{Q}\mathbf{B}_0\mathbf{t}_0 \neq 0 \in S_{RY} \end{aligned}$$

392 and also

$$\tilde{\mathbf{y}}_1 = \hat{\mathbf{y}}^* - \hat{\mathbf{y}} = (\mathbf{y}_0 + \mathbf{Q}_0\mathbf{S}'_0\Delta\mathbf{Q}\mathbf{B}_0\mathbf{t}_0) - \mathbf{y}_0 = \mathbf{Q}_0\mathbf{S}'_0\Delta\mathbf{Q}\mathbf{B}_0\mathbf{t}_0 \neq 0 \in S_{MY}.$$

393 where the residues $\tilde{\mathbf{y}}_1$ and $\tilde{\mathbf{y}}_2$ are used to “detect the disturbance”.

Class 6. A significant change in the process condition produces
measurements that follow the correlation structure captured by the
undisturbed PLSR model. This type of disturbance can be represented
by changes in the population parameters of $\mathbf{t}_0 \sim N(\mathbf{0}, \Lambda_0)$, i.e., we have
to assume a displacement of $E\{\mathbf{t}_0\}$ from $\mathbf{0}$ to a $\boldsymbol{\mu}_t \neq \mathbf{0}$, or a significant
change in the variability from Λ_0 to $\Lambda_t \neq \Lambda_0$. Hence, the anomaly in
this case produces

$$\mathbf{t} = \mathbf{t}_0 + \Delta\mathbf{t} \sim N(\boldsymbol{\mu}_t, \Lambda_t) \quad (\text{Data generation})$$

with a $\Delta\mathbf{t}$ of magnitude such that: $T_t^2 = \|\Lambda_0^{-1/2}\mathbf{t}\|^2 = \|\Lambda_0^{-1/2}(\mathbf{t}_0 + \Delta\mathbf{t})\|^2 \geq \tau_\alpha^2$ (disturbance detection).

The above results are summarized in Table 2. The highlighted dis-
crimination patterns indicate the statistics that are activated as soon
as the measurements (\mathbf{x}, \mathbf{y}) bring information about a localized model
mismatch. The six analyzed anomalies can qualitatively be grouped
into the following three categories: sensor fault (classes 1 and 2), pro-
cess change (classes 3, 4 and 5), and excessive (quality) operation
change (class 6).

Some final comments about the effect of the dimension A on the dis-
criminating sensitivity seem convenient at this point. Recall that the
predictor variables \mathbf{x} are assumed as belonging to an m dimensional
space, i.e., $\mathbf{x} \in \mathbb{R}^m$. This space is then projected onto the subspaces S_{MX}
and S_{RX} where $\dim(S_{MX}) = A \leq m$ and $\dim(S_{RX}) = m - A$. Hence, when
 $A \rightarrow m$, the subspace S_{RX} (useful for detecting sensor faults in the pred-
ictor variables \mathbf{x}) reduces, leaving information of possible anomalous
measurements in S_{MX} . It is then understandable that when A increases
beyond a certain point, the ability for failure detection on S_{RX} tends to
disappear. At the same time, too small values of A might move the cor-
related behavior to S_{RX} , playing an interfering roll in the residue index
 SPE_x . A similar reasoning can be done with the output variables \mathbf{y} , origi-
nally in a space of dimension p , i.e., $\mathbf{y} \in \mathbb{R}^p$.

Table 2
Expected statistics pattern for each anomaly class.

Anomaly class	Statistics composing I_{TC} (associated subspaces)			
	T_t^2 / τ_α^2 (S_{MX})	$SPE_x / \delta_{x,\alpha}^2$ (S_{RX})	$SPE_{y1} / \delta_{y1,\alpha}^2$ (S_{MY})	$SPE_{y2} / \delta_{y2,\alpha}^2$ (S_{RY})
Class 1: fault of sensors in \mathbf{x} (ξ)	–	++	–	–
Class 2: fault of sensors in \mathbf{y} (η)	–	–	–	++
Class 3: changes in correlations of \mathbf{x} ($\Delta\mathbf{P}$)	–	++	++	–
Class 4: changes in the intrinsic gains ($\Delta\mathbf{B}$)	–	–	++	–
Class 5: changes in correlations of \mathbf{y} ($\Delta\mathbf{Q}$)	–	–	++	++
Class 6: excessive change in $(\boldsymbol{\mu}_t, \Lambda_t)$	++	–	–	–

++: significant value. –: negligible value.

3.3. Isolation of disturbed variables or disturbing sources

When trying to localize a faulty sensor or detect an abnormal correlation, the identification of the involved variables becomes very helpful. The use of contribution analysis to characterize an anomaly has been previously proposed [11]. The preliminary classification of the anomalous event according to Table 2, enable us to restrict the search problem to one or two statistics.

A simple strategy for decomposing the four statistics in Eq. (22) is also proposed here. The arrangement can be applied to any quadratic form $I^2 = \mathbf{z}'\mathbf{A}\mathbf{z}$ (like T_1^2 , $SPE_{\mathbf{x}}$, SPE_{y1} , or SPE_{y2}), to reveal the contribution intensity of each variable z_i . This decomposition is performed as follows:

$$I^2 = \mathbf{z}'\mathbf{A}\sum_{i=1}^n \mathbf{z}_i = \sum_{i=1}^n \mathbf{z}'\mathbf{a}_i z_i = \sum_{i=1}^n cI^2(z_i) \quad (24)$$

where $\mathbf{a}_i = [a_{i1} \dots a_{in}]'$ is the i -th column of the matrix \mathbf{A} , $\mathbf{z}_i \triangleq [0 \dots z_i \dots 0]'$ ($n \times 1$) is a vector with only a nonzero value in the i -th position, and $cI^2(z_i)$ stands for the contribution of z_i to I^2 . This contribution captures the gradient of the statistic in the z_i direction, i.e.,

$$\frac{1}{2} \nabla_{\mathbf{z}}(I^2) \cdot \mathbf{z}_i = \frac{1}{2} \nabla_{\mathbf{z}}(\mathbf{z}'\mathbf{A}\mathbf{z}) \cdot \mathbf{z}_i = \mathbf{z}'\mathbf{a}_i z_i = cI^2(z_i). \quad (25)$$

Note that it can also be written in terms of the projections by substituting the relationships $\mathbf{R}'\tilde{\mathbf{x}} = \mathbf{R}'\mathbf{x}(\mathbf{I}-\mathbf{P}\mathbf{R}')\tilde{\mathbf{x}} = (\mathbf{I}-\mathbf{P}\mathbf{R}')\mathbf{x}, \mathbf{S}'\tilde{\mathbf{y}} = \mathbf{S}'\mathbf{y}$ and $(\mathbf{I}-\mathbf{Q}\mathbf{S}')\tilde{\mathbf{y}}_2 = (\mathbf{I}-\mathbf{Q}\mathbf{S}')\mathbf{y}$ in Eqs. (16, 17, 19, 20), yielding

$$cT_1^2(x_i) = \mathbf{x}'\mathbf{a}_i x_i \equiv \tilde{\mathbf{x}}'\mathbf{a}_i \tilde{x}_i, \quad \text{with } \mathbf{A} = \mathbf{R}\mathbf{A}^{-1}\mathbf{R}' = [\mathbf{a}_1 \dots \mathbf{a}_m]_{m \times m} \quad (26)$$

$$cSPE_{\mathbf{x}}(x_i) = \tilde{\mathbf{x}}'\mathbf{a}_i \tilde{x}_i, \quad \text{with } \mathbf{A} = (\mathbf{I}-\mathbf{P}\mathbf{R}')'(\mathbf{I}-\mathbf{P}\mathbf{R}') = [\mathbf{a}_1 \dots \mathbf{a}_m]_{m \times m} \quad (27)$$

$$cSPE_{y1}(y_j) = [\tilde{\mathbf{y}}_1' \tilde{\mathbf{x}}']\mathbf{a}_j \tilde{y}_j, \quad cSPE_{y1}(y_j) = [\tilde{\mathbf{y}}_1' \tilde{\mathbf{x}}']\mathbf{a}_j \tilde{y}_j^* \quad (28)$$

with $\mathbf{A} = \begin{bmatrix} \mathbf{S}\mathbf{S}' & -\mathbf{S}\mathbf{B}\mathbf{R}' \\ -\mathbf{R}\mathbf{B}\mathbf{S}' & \mathbf{R}\mathbf{B}^2\mathbf{R}' \end{bmatrix} = [\mathbf{a}_1 \dots \mathbf{a}_p \mathbf{a}_{p+1} \dots \mathbf{a}_{p+m}]_{(p+m) \times (p+m)}$

$$cSPE_{y2}(y_j) = \tilde{\mathbf{y}}_2'\mathbf{a}_j \tilde{y}_{2,j}, \quad \text{with } \mathbf{A} = (\mathbf{I}-\mathbf{Q}\mathbf{S}')'(\mathbf{I}-\mathbf{Q}\mathbf{S}') = [\mathbf{a}_1 \dots \mathbf{a}_p]_{p \times p} \quad (29)$$

Then, by combining Eqs. (22), (24), (26)–(29) gives

$$I_{TC} = I_{MX}(\mathbf{x}) + I_{RX}(\mathbf{x}) + I_{RY1}(\mathbf{x}, \mathbf{y}) + I_{RY2}(\mathbf{y})$$

$$I_{TC} = \sum_{i=1}^m cI_{MX}(x_i) + \sum_{i=1}^m cI_{RX}(x_i) + \left(\sum_{i=1}^m cI_{RY1}(x_i) + \sum_{j=1}^p cI_{RY1}(y_j) \right) + \sum_{j=1}^p cI_{RY2}(y_j) \quad (30)$$

where e.g., the term $cI_{MX}(x_i) = cT_1^2(x_i)/\tau_{\alpha}^2$ in Eq. (30) is the normalized contribution of x_i to I_{TC} through the projection on S_{MX} (see Eq. (26)). Furthermore, since I_{MX} has a significance level of 1, then the significance level of their contributions cI_{MX} is also adopted equal to 1. In particular, $cT_1^2(x_i) = x_i \mathbf{a}_i' \mathbf{x}$ (Eq. (26)) is equivalent to the contribution defined by Westerhuis et al. [29]; and it tends to the contribution reported by Alvarez et al. [30], when $S_{MX} \rightarrow \mathbb{R}^m$, because $D_{\mathbf{x}} \rightarrow T_{\mathbf{x}}^2 = \mathbf{x}'\mathbf{R}_{\mathbf{x}}^{-1}\mathbf{x}$ with $\mathbf{R}_{\mathbf{x}} > 0$.

The variable contribution defined by Eq. (24) guarantees a correct diagnosis when \mathbf{A} is positive semidefinite [11], which always holds for the four statistics of Eqs. (26)–(29). A reliable isolation of faulty sensors must correctly indicate the disturbed variable. For example, a fault in the k -th sensor of \mathbf{x} can be represented as $\mathbf{x} = \mathbf{x}_0 + f_k \boldsymbol{\xi}_k$ [10], where f_k is the fault magnitude and $\boldsymbol{\xi}_k = [00 \dots 1 \dots 0]'$ is the fault direction. If the faulty measurement projection is mostly included in S_{RX} (see Class 1), then it can be expressed as: $\tilde{\mathbf{x}} \approx f_k \boldsymbol{\xi}_k$ (i.e. $\tilde{x}_k \approx f_k$ and $\tilde{x}_i \approx 0 \forall i \neq k$).

Thus, by including such value into the contributions to I_{TC} (depending on the subspace), it results:

$$I_{MX}, I_{RY1}, I_{RY2} \approx 0,$$

$$cI_{RX}(x_i) = \tilde{\mathbf{x}}'\mathbf{a}_i \tilde{x}_i / \delta_{\mathbf{x},\alpha}^2 = \begin{cases} f_k \boldsymbol{\xi}_k' \mathbf{a}_i \mathbf{0} / \delta_{\mathbf{x},\alpha}^2 = 0 & \text{for } i \neq k \\ f_k \boldsymbol{\xi}_k' \mathbf{a}_i f_k / \delta_{\mathbf{x},\alpha}^2 = f_k^2 a_{ii} / \delta_{\mathbf{x},\alpha}^2 & \text{for } i = k \end{cases} \quad (31)$$

A correct diagnosis occurs when the contribution of the non-faulty variable is less than or equal to the contribution of the faulty variable, i.e. when $cI_{RX}(x_k) \geq 0$ (see Eq. (31)). Therefore, a correct isolation is guaranteed when $a_{ii} \geq 0$, which is always true since $\mathbf{A} \geq 0$ (Eq. (27)).

4. Simulation test

The described monitoring procedure is now tested with random measurements obtained from the numerical simulation of two systems of different complexity. The first system is a synthetic example representing a hypothetical static process, where the internal data structure was arbitrary chosen. The second application is a more realistic problem where the variables of a dynamic process under normal conditions are empirically modeled by PLSR.

4.1. A four-state static process

The synthetic example is first simulated to better interpret the proposed methodology as a monitoring tool. The normal operation of the chosen system includes four internal states, which are represented by the following four points of its latent space (\mathbf{t} -scores): $\{(t_1^*, t_2^*)\}_{1 \dots 4} = \{(1,1), (1,3), (3,3), (3,1)\}$. The “measurements” of the external variables, \mathbf{x} and \mathbf{y} , are generated by adding zero-mean Gaussian random noises ($\boldsymbol{\varepsilon}_i, i = 1 \dots 4$) to the PLSR correlation structure characterized by the arbitrary-selected process matrices \mathbf{P}, \mathbf{Q} , and \mathbf{B} , as follows:

$$\begin{cases} \text{Internal part} & \begin{cases} \mathbf{t}_0 = \mathbf{t}^* + \boldsymbol{\varepsilon}_1, & \boldsymbol{\varepsilon}_1 \sim N(\mathbf{0}, 0.1^2 \mathbf{I}_2), \\ \mathbf{u} = \mathbf{B}\mathbf{t}_0 + \boldsymbol{\varepsilon}_2, & \mathbf{B} = \text{diag}(2, 0.5), \quad \boldsymbol{\varepsilon}_2 \sim N(\mathbf{0}, 0.05^2 \mathbf{I}_2), \end{cases} \\ \text{External part} & \begin{cases} \mathbf{x} = \mathbf{P}\mathbf{t}_0 + \boldsymbol{\varepsilon}_3, & \mathbf{P} = [\mathbf{p}_1 \quad \mathbf{p}_2], \quad \boldsymbol{\varepsilon}_3 \sim N(\mathbf{0}, 0.05^2 \mathbf{I}_7), \\ \mathbf{y} = \mathbf{Q}\mathbf{u} + \boldsymbol{\varepsilon}_4, & \mathbf{Q} = [\mathbf{q}_1 \quad \mathbf{q}_2], \quad \boldsymbol{\varepsilon}_4 \sim N(\mathbf{0}, 0.05^2 \mathbf{I}_5), \end{cases} \end{cases} \quad (32)$$

$\mathbf{p}_1 = [0.4045, 0, 0.5394, 0.2697, 0.1348, 0, 0.6742]'$,
 $\mathbf{p}_2 = [0, 0.7906, 0.1581, -0.1581, -0.3162, 0.4743, 0]'$,
 $\mathbf{q}_1 = [0.5883, 0, -0.1961, 0, 0.7845]'$,
 $\mathbf{q}_2 = [0.0081, 0.7054, 0.0678, -0.7054, 0.0109]'$

This model is used to simulate 40 multivariate observations under ‘normal conditions’ and the generated dataset is used to fit the PLSR model. The selection of $A = 2$ is determined by monitoring the simultaneous deflation of \mathbf{X} and \mathbf{Y} [18]; in this way the errors regarding the “true” matrices \mathbf{Q}, \mathbf{B} , and \mathbf{P} are negligible. The control limits $\tau_{\alpha}^2, \delta_{\mathbf{x},\alpha}^2, \delta_{\mathbf{y},\alpha}^2$ are calculated as explained in Appendix B.

Table 3 shows six simulated anomalies (one for each class in Table 2): a) anomalies of classes 1 and 2 correspond to sensor biases that are simulated by disturbing the measurements \mathbf{x} and \mathbf{y} ; b)

Table 3 Simulated scenarios of anomalies.

Location	Anomaly class	Magnitude of the change/fault	I_{TC}/I_a ($I_a = 2.266$)
$k = 11$	1	$\Delta \mathbf{x} = [0.3 \ 0 \ 0 \ 0 \ 0.25 \ 0]'$ (Multiple fault)	1.980
$k = 19$	2	$\Delta \mathbf{y} = [0.35 \ 0 \ 0 \ 0]'$ (Single fault)	2.381
$k = 27$	3	$\Delta \mathbf{p}_2 = [0 \ 0.28 \ 0 \ 0 \ -0.07 \ 0.14 \ -0.14]'$	5.799
$k = 35$	4	$\Delta \mathbf{B}_{22} = 0.25$	3.291
$k = 43$	5	$\Delta \mathbf{q}_1 = [-0.05 \ 0.025 \ 0.05 \ 0.025 \ -0.1]'$	3.700
$k = 51$	6	$\Delta \mathbf{t} = [0 \ 6]'$	2.715

510 anomalies of classes 3, 4, and 5 are implemented by altering the process
 511 matrices; and c) anomaly of class 6 consists in adding up a change Δt to
 512 t_0 , such that $I_{TC} > I_{ce}$. Each fault is simulated by affecting only one sample
 513 point at a discrete time, k ; and immediately the anomaly is canceled
 514 from $k + 1$ onwards. These anomalies represent a hard test for evaluat-
 515 ing the ability of the method.

Fig. 3a shows the time evolution of the I_{TC} detection index and its
 516 component statistics. The alarm condition is triggered at a given sample
 517 k , when the I_{TC} index overpasses the control limit. The index I_{TC} proved
 518 to be effective for detecting all simulated anomalies. Table 3 shows the
 519 proportion of the variation of I_{TC} with respect to control limit for each
 520 simulated fault-scenario. The patterns of the statistics recorded in
 521

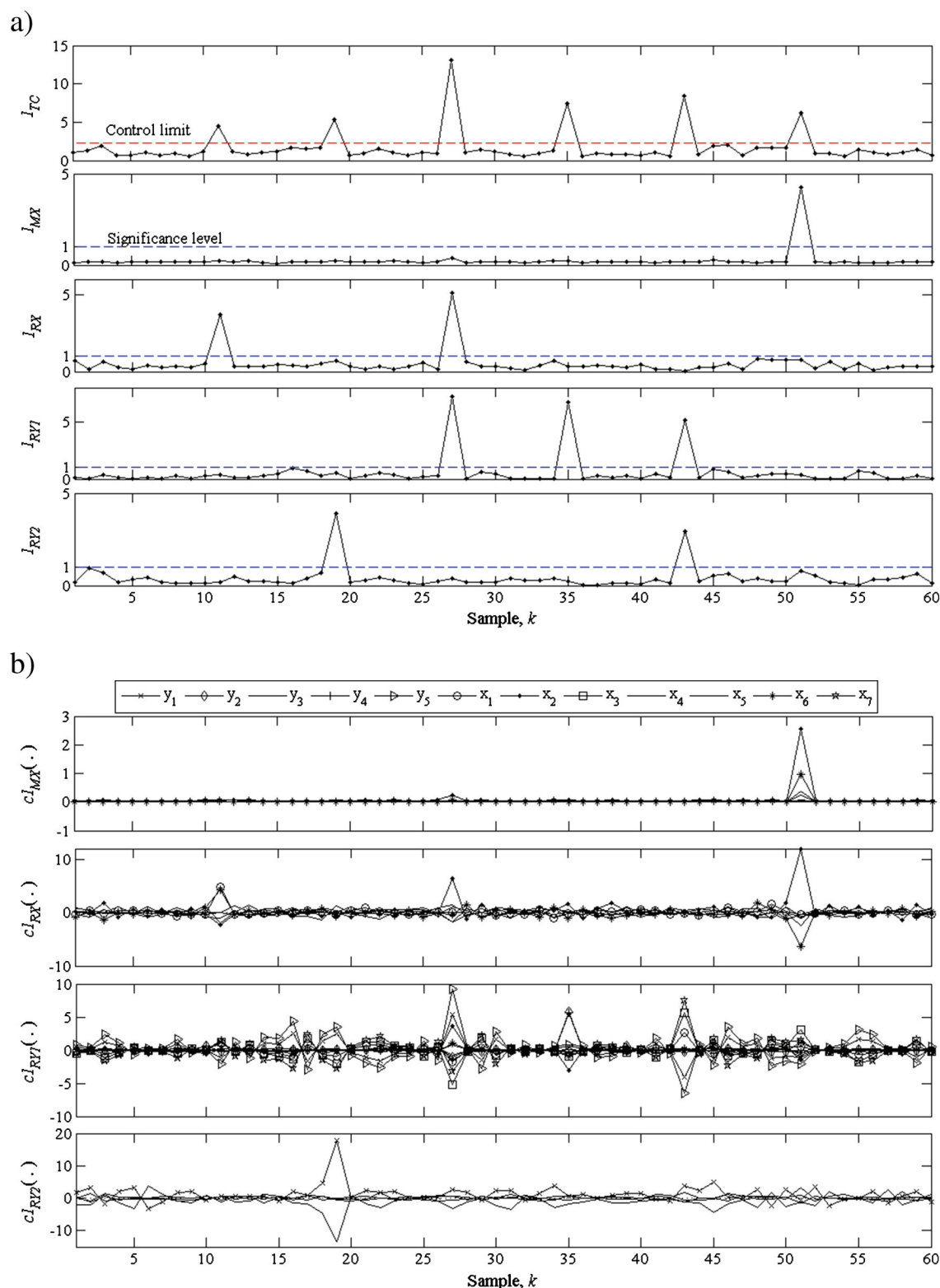


Fig. 3. Simulation example based on a statistic process. (a) Temporal evolution of the combined index I_{TC} and of its component statistics. (b) Variable contributions to each component statistics of I_{TC} .

Fig. 3a along with the information given in Table 2 allow an unambiguous classification of each anomaly class (see Table 4). Fig. 3b shows the instantaneous variable contributions to each component statistic of I_{TC} . For example, at $k = 11$, the main contributions to I_{TC} are $cl_{RX}(x_1)$ and $cl_{RX}(x_6)$; and therefore faults in sensors x_1 and x_6 are diagnosed (first row of Table 4). Similarly, at $k = 19$, $cl_{RY2}(y_1)$ diagnoses a fault in sensor y_1 (second row of Table 4). The remaining results in Table 4 are summarized as follows: a) at $k = 27$ and $k = 43$, correlation changes in \mathbf{x} and \mathbf{y} are respectively diagnosed, which indicate major changes in the original external correlations (i.e., \mathbf{P} and \mathbf{Q} in Eq. (32)); b) at $k = 35$, $cl_{RY1}(y_2)$ and $cl_{RY1}(y_4)$ diagnose an upset of the t_2 - u_2 inner relation, because the contributions of y_2 and y_4 are more correlated with u_2 (see the main components of \mathbf{q}_2 in Eq. (32)); and c) at $k = 51$, $cl_{MX}(x_2)$ and $cl_{MX}(x_6)$ diagnose an excessive change in the normal operation point (though still following the correlation structure), because the contributions of x_2 and x_6 are more correlated with t_2 (see the main components of \mathbf{p}_2 in Eq. (32)).

4.2. Application to a chemical process with feedback control

The chemical process described by Yoon and MacGregor [31] is here adopted to evaluate the proposed method of process monitoring with fault detection and isolation. The process consists of a first-order chemical reaction carried out in a non-isothermal continuously-stirred tank reactor, where both the solute (A) and the solvent (S) are continuously fed into the reactor (Fig. 4). This example has widely been used in the literature to test other methods of fault detection and diagnosis; e.g. methods based on both linear [31] and nonlinear [14,32,33] LV models. The mathematical model of the process is given by [31]:

$$\begin{aligned}
 F &= F_A + F_S, \\
 C_{A0} &= (C_{AA}F_A + C_{AS}F_S)/F, \\
 \frac{dC_A}{dt} &= \frac{F}{V}C_{A0} - \frac{F}{V}C_A - k_0e^{-E/RT}C_A, \\
 \frac{dT}{dt} &= \frac{F}{V}(T_0 - T) - \frac{aF_c^{3/2}}{(F_c + aF_c^{1/2}/2\rho_c C_{PC})V\rho C_p}(T - T_c) \\
 &\quad + \frac{(-\Delta H_r)}{\rho C_p}k_0e^{-E/RT}C_A, \\
 Q &= (-\Delta H_r)Vk_0e^{-E/RT}C_A,
 \end{aligned}
 \tag{33}$$

with the following parameters: $V = 1 \text{ (m}^3\text{)}$, $\rho = 10^6 \text{ (g/m}^3\text{)}$, $\rho_c = 10^6 \text{ (g/m}^3\text{)}$, $E/R = 8330.1 \text{ (K)}$, $C_p = 1 \text{ (cal/gK)}$, $C_{PC} = 1 \text{ (cal/gK)}$, $k_0 = 10^{10} \text{ (m}^3\text{/kmol} \times \text{min)}$, $a = 1.678 \times 10^6 \text{ (cal/min} \times \text{K)}$, and $\Delta H_r = -1.3 \times 10^7 \text{ (cal/kmol)}$.

The process is monitored from the following measurements: the inlet A flow rate (F_A), the inlet A concentration (C_{AA}), the inlet solvent flow rate (F_S), the A concentration in the solvent (C_{AS}), the reactant mixture temperature (T_0), the cooling water temperature (T_C), the coolant flow rate (F_C), the outlet concentration (C_A), the outlet temperature (T), and the reaction heat rate (Q). These measurements are arranged as follows: $\mathbf{x} = [F_A \ C_{AA} \ F_S \ C_{AS} \ T_0 \ T_C \ F_C]^T$ (process inputs), and $\mathbf{y} = [C_A \ T \ Q]^T$ (process

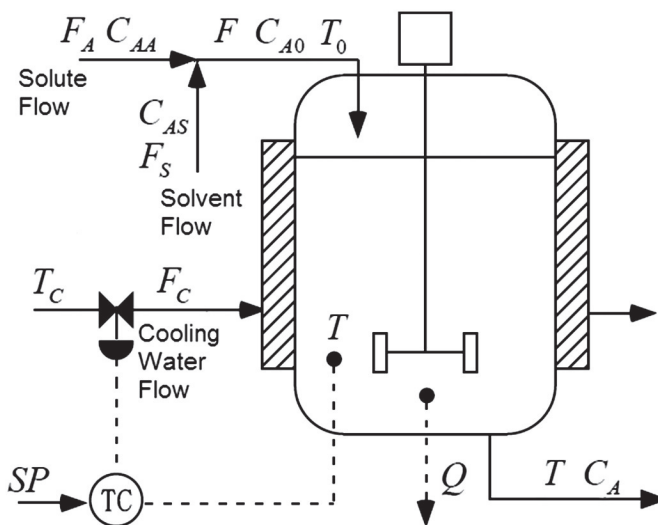


Fig. 4. Simulation example based on a dynamic process. Flow diagram of the process with 7 input- and 3 output measured variables.

outputs). Additionally, the following measured process disturbances were selected: C_{AA} , F_S , C_{AS} , T_0 , and T_C , which were simulated (under both normal and fault conditions) through a first-order autoregressive (AR) model, i.e.: $x_i(k) = \phi_i x_i(k-1) + \sigma_{e_i} e(k)$, where $e(k) \sim N(0,1)$ and $\sigma_{e_i}^2$ is the process variance, and ϕ_i is the AR parameter. Random measurement noises are added to all process variables according to: $x_{i,meas}(k) = x_i(k) + \sigma_{m_i} m(k)$ and $y_{i,meas} = y_i(k) + \sigma_{m_i} m(k)$, where $m(k) \sim N(0,1)$ and $\sigma_{m_i}^2$ is the noise variance. The parameters of the disturbances and measurement noises are shown in Table 5.

The reaction temperature is regulated through a PI controller, implemented as: $dF_C/dt = K_C d(SP_T - T)/dt + K_C(SP_T - T)/T_i$, with the following parameters: $K_C = -1.5$ and $T_i = 5.0$. The adopted initial conditions are: $T_0 = 370.0 \text{ K}$, and $C_A = 0.8 \text{ kmol/m}^3$. The remaining variables are kept constant at the following values: $T_C = 365.0 \text{ K}$, $F_C = 15 \text{ m}^3\text{/min}$, $T = 368.25 \text{ K}$, $F_S = 0.9 \text{ m}^3\text{/min}$, $F_A = 0.1 \text{ m}^3\text{/min}$, $C_A = 0.8 \text{ kmole/m}^3$, $C_{AS} = 0.1 \text{ kmol/m}^3$, and $C_{AA} = 19.1 \text{ kmol/m}^3$. All variables were sampled at regular intervals of one minute. Under normal conditions, 200 samples were used to define the model calibration dataset. The following PLSR model was identified in this work:

$$\mathbf{y}(k) = \mathbf{QBR}'\mathbf{x}(k-1),
 \tag{34}$$

where $\mathbf{y}(k)$ represents the response vector at the discrete time k , and $\mathbf{x}(k-1)$ is the predictor vector at $k-1$. Eq. (34) represents a static model with a one-point delayed input. Based on criteria given by Godoy et al. [18], three LVs were required to fit the PLSR model. Since the number of LVs equals the number of process outputs, then the response space

Table 4 Anomaly classification and identification of disturbed variables.

Sample point	$cl_{MX}(\cdot)$	$cl_{RX}(\cdot)$	$cl_{RY1}(\cdot)$	$cl_{RY2}(\cdot)$	Diagnosis of the abnormal event	Diagnosed class
$k = 11$	-	x_1, x_6	-	-	Faults in sensors of x_1 and x_6	1
$k = 19$	-	-	-	y_1	Fault in the sensor of y_1	2
$k = 27$	-	x_2	y_5, y_1, x_2	-	Correlation changes in \mathbf{x}^a	3
$k = 35$	-	-	y_2, y_4	-	Change in the intrinsic gain	4
$k = 43$	-	-	x_7, x_3	y_1	Correlation changes in \mathbf{y}^b	5
$k = 51$	x_2, x_6	-	-	-	Excessive operation change	6

^a Main changes occur in x_2 .
^b Main changes occur in y_1 .

Table 5 Parameters for simulating process disturbances and measurement noises.

	Process disturbances		Measurement noises
	ϕ_i	$\sigma_{e_i}^2$	$\sigma_{m_i}^2$
$F_A (x_1)$			4.0×10^{-6}
$C_{AA} (x_2)$	0.9	0.475×10^{-1}	1.0×10^{-2}
$F_S (x_3)$	0.9	0.190×10^{-2}	4.0×10^{-6}
$C_{AS} (x_4)$	0.5	1.875×10^{-3}	2.5×10^{-5}
$T_0 (x_5)$	0.9	0.475×10^{-1}	2.5×10^{-3}
$T_C (x_6)$	0.9	0.475×10^{-1}	2.5×10^{-3}
$F_C (x_7)$			1.0×10^{-2}
$C_A (y_1)$			2.5×10^{-5}
$T (y_2)$			4.0×10^{-4}
$Q (y_3)$			1.0×10^3

586 cannot be separated into two subspaces. Anyway, the monitoring technique can still be applied.

587 To evaluate the performance of the proposed technique, four types of faults are simulated as follows: F.1) a (non-propagating) sensor fault, simulated as a bias of +2.4 K in T_0 ; F.2) a sensor fault (propagated by the PI control loop), simulated as a bias of +1.5 K in T ; F.3) a process change, simulated as a slow drift in the reaction kinetics, given by $k_0(k) = 0.999 k_0(k - 1)$; and F.4) a process disturbance, simulated as an unmeasured increment in the reactant mixture temperature, given by $T_{0,in} = T_0 + 0.03k$. According to the classification given by Yoon and MacGregor [31], F.1 is a simple fault while F.2, F.3, and F.4 are complex faults. The proposed cases are qualitatively similar to fault scenarios investigated in previous works [14,31–33]. Also, a quite similar process has been used to test a diagnosis technique based on a linear LV model, with the fault scenarios F.1 and F.2 [34].

601 For simplicity, each fault was introduced at $k = 50$, and was kept until the end of the simulation. All cases were simulated along 400 min, and therefore 400 samples were collected. The simulation results are depicted in Figs. 5–8. The first row of each figure represents the fault detection pattern, where the ordinates are normalized to I_{TC}/I_{α} and therefore the control limit is 1. The three last rows of each figure constitute the basis of the diagnosis strategy based on the contribution analysis.

602 For the fault F.1), Fig. 5 shows a significant change in $cl_{RX}(x_5)$ for $k > 50$, while both $cl_{MX}(\cdot)$ and $cl_{RY1}(\cdot)$ remain close or slightly below 1. The variable $x_5 (=T_0)$ was identified as dominant, with a neat prevalence on I_{RX} and smaller effects on the other subspaces.

603 In the case of F.2), Fig. 6 shows a rapid alarm in I_{RY1} at $k = 51$, while negligible contributions to I_{MX} and I_{RX} are observed. Around 30 min after the beginning of the fault ($k = 51-80$), the variable contributions to I_{RY1} properly indicate the root source (i.e., the bias in T). Since T is a controlled variable, the bias fault is gradually removed by effect of the closed-loop action, and the anomaly is then transferred to other variables. From $k = 80$ onwards, the PI controller propagates the anomaly to the variable $F_C(x_7)$, which modified T and C_A , as it is notified by cl_{RY1} . Additionally, an alert in I_{MX} diagnoses a change in the operating point together with an alert in I_{RX} that indicates a correlation change in $F_C(x_7)$ with respect to the remaining variables (i.e., x_1, \dots, x_6). The disturbed x_7 is correctly diagnosed by the contributions to I_{MX} and I_{RX} . The

624 variable contributions to each component statistic exhibit transient responses until the process is settled to the new steady state.

625 The simulated fault F.3) corresponds to a gradual degradation of the reaction rate, as typically caused by catalyst poisoning. The process change was detected at $k \approx 170$, after collection of around 120 samples. The high levels of $cl_{RY1}(y_1)$ and $cl_{RY1}(y_3)$ in Fig. 7 indicate that both C_A and Q cannot be adequately predicted. Since no predictor variable is attributed to such changes, then it can be inferred that the anomaly is due to the modification of some parameter of the plant (k_0 in this case). Note that k_0 is related to T , C_A , and Q (see Eq. (33)), but T is regulated to SP_T by the PI controller.

626 Fault F.4) consists in introducing a slow drift of +0.03 K/min in T_0 . This continuous temperature rise indirectly causes an increase in the inlet coolant flow rate $F_C(x_7)$, as required to keep the reactor temperature constant at its desired value. According to Fig. 8, a correlation loss between F_C and the remaining input variables is first diagnosed by a high $cl_{RX}(x_7)$; then, a change in the operating point of F_C is diagnosed by a high $cl_{MX}(x_7)$.

627 The four analyzed example faults allow a direct comparison with some detection and diagnosis studies previously-reported [14,31–34]. Each of these works investigated a different (linear or nonlinear) LV technique that was applied to the evaluation of only a limited number of the described fault scenarios F.1 to F.4. More specifically, a Kernel PCA technique was applied to F.1, F.2, and F.3 [14], a steady-state fault signature technique was applied to F.1 and F.2 [31], a nonlinear multiscale modeling technique was applied to F.1, F.3, and F.4 [33], and a contribution plot without smearing effect was applied to F.1 and F.2 [34]. Besides, a technique based on Gaussian process LV models was evaluated onto the fault scenario F.2, but with purposes of fault detection only [32]. In contrast, the technique presented in this work is linear and successfully detects and diagnoses the four simulated fault scenarios. In general, it was observed that the detection sensitivity (i.e., the minimal disturbance that triggers an out-of-control of the index I_{TC}) is equivalent to the sensitivity achieved by the individual approaches of [14,31–34] in the cases of the fault scenarios F.1, F.2, and F.4. However, the present approach is more sensitive than that used in [14,33] for the fault scenario F.3, and allows adequate detection and diagnosis even under lower levels of the reaction degradation. Additionally, it should be noticed that the

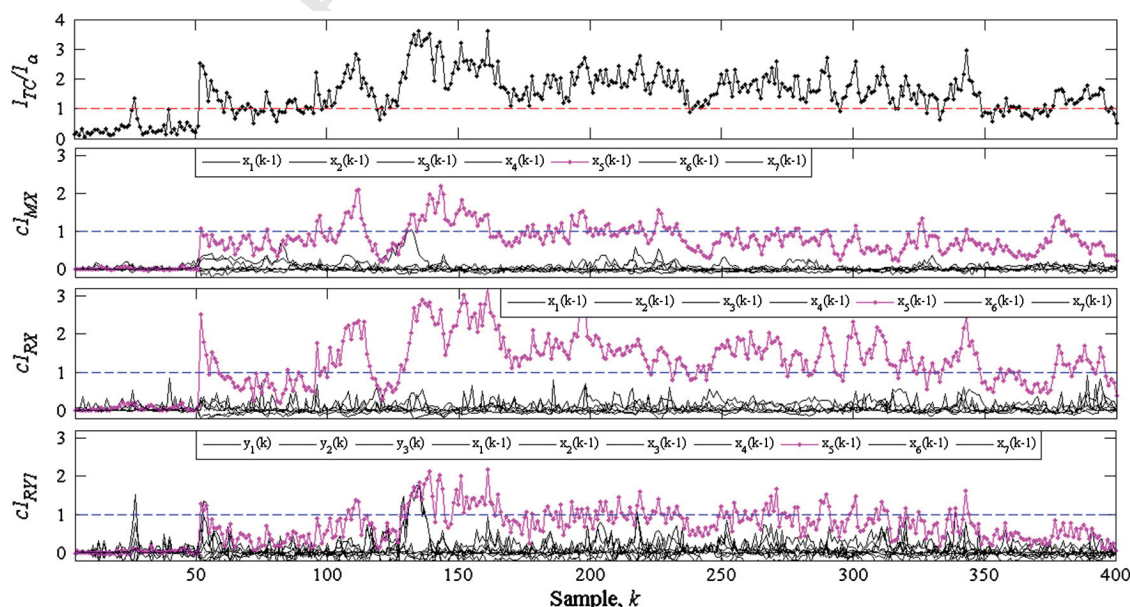


Fig. 5. Simulation of fault F.1): bias in the measurement of T_0 . The contributions to the statistic I_{RX} identify the variable $x_5 (=T_0)$ as the source of the fault.

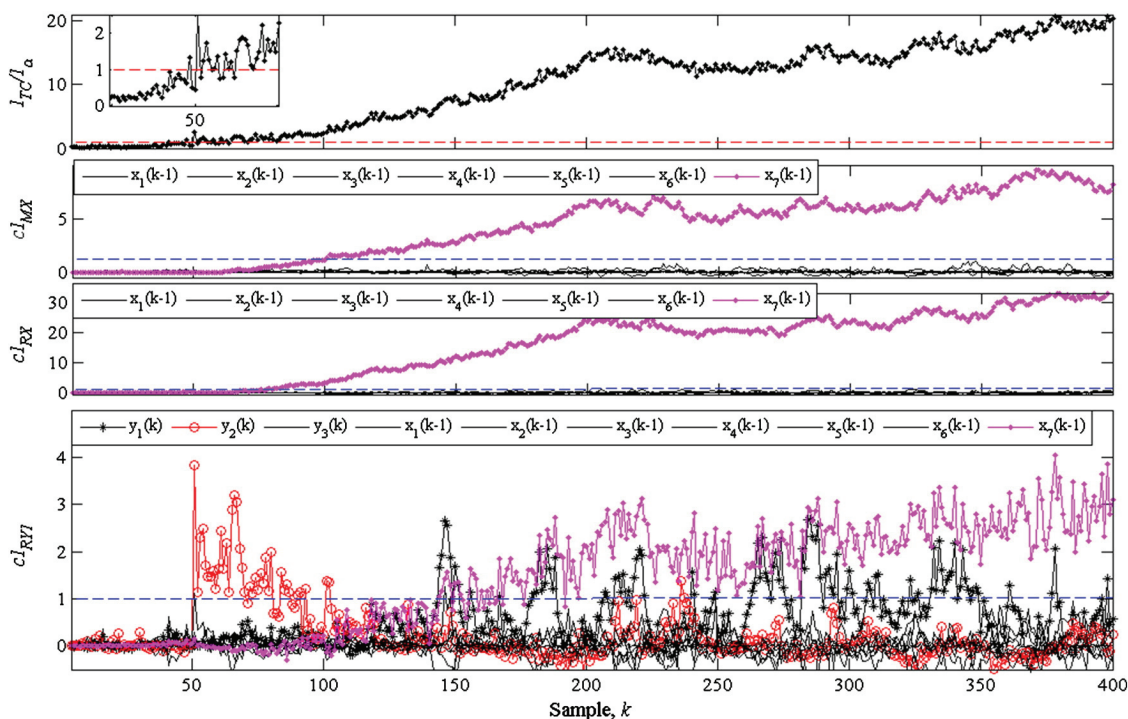


Fig. 6. Simulation of fault F.2): bias in the measurement of T . At $50 < k < 80$, the contributions to the statistic I_{RV1} identify the variable $y_2 (=T)$ as the source of the fault.

662 present detection and diagnosis procedure, implemented through an
 663 anomaly classification step followed by a further variable identification,
 664 is only based on theoretical considerations that enabled a proper diagnosis
 665 of several classes of faults (Table 4).

666 5. Conclusions

667 The proposed monitoring technique is based on a PLSR model initially
 668 designed under 'in-control' conditions, and is especially useful for monitoring
 669 processes that exhibit collinear measurements. The fundamentals
 670 of the method are based on detecting meaningful deviations of the
 671 measurements from their expected behaviors, which in turn serve for

diagnosing abnormal events. The extension of the PLSR modeling strategy
 672 consisted in a new PLS-decomposition that included more specific statistics,
 673 such as the distance to the regression model. By means of several
 674 numerical simulations, it was verified that the proposed method was
 675 effective for detecting and diagnosing different anomalies.
 676

The proposed detection index, I_{TC} , involves a balanced merging of
 677 several scaled metrics; and it represents a statistical distance that considers
 678 the correlation structure of the process as well as three
 679 Euclidean distances to the model. The analytical expression of I_{TC}
 680 [Eq. (22)] contains an optimized combination of statistics. In fact, if a
 681 new statistics were added (e.g., T_u^2), then the new combined index
 682 would be: $I_{TC}^* = 2I_{MX} + I_{RX} + I_{RV1} + I_{RV2} = I_{TC} + I_{MX}$. Thus, the
 683

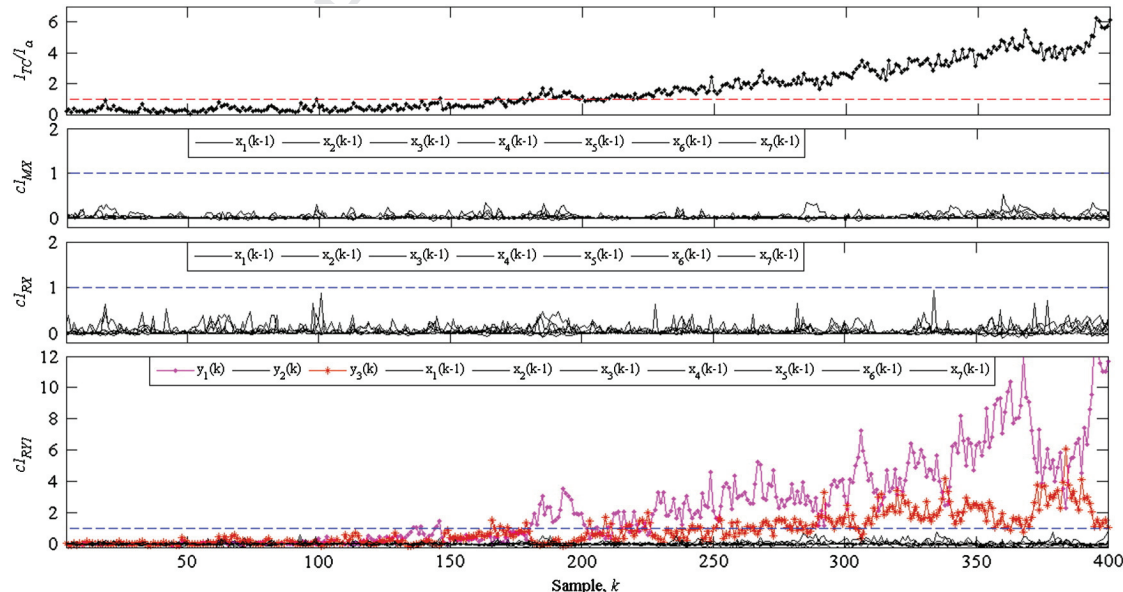


Fig. 7. Simulation of fault F.3): degradation of the reaction rate. At $k > 170$, the contributions to the statistic I_{RV1} indicate that predictions of the variables $y_1 (=C_A)$ and $y_3 (=Q)$ could be highly erroneous.

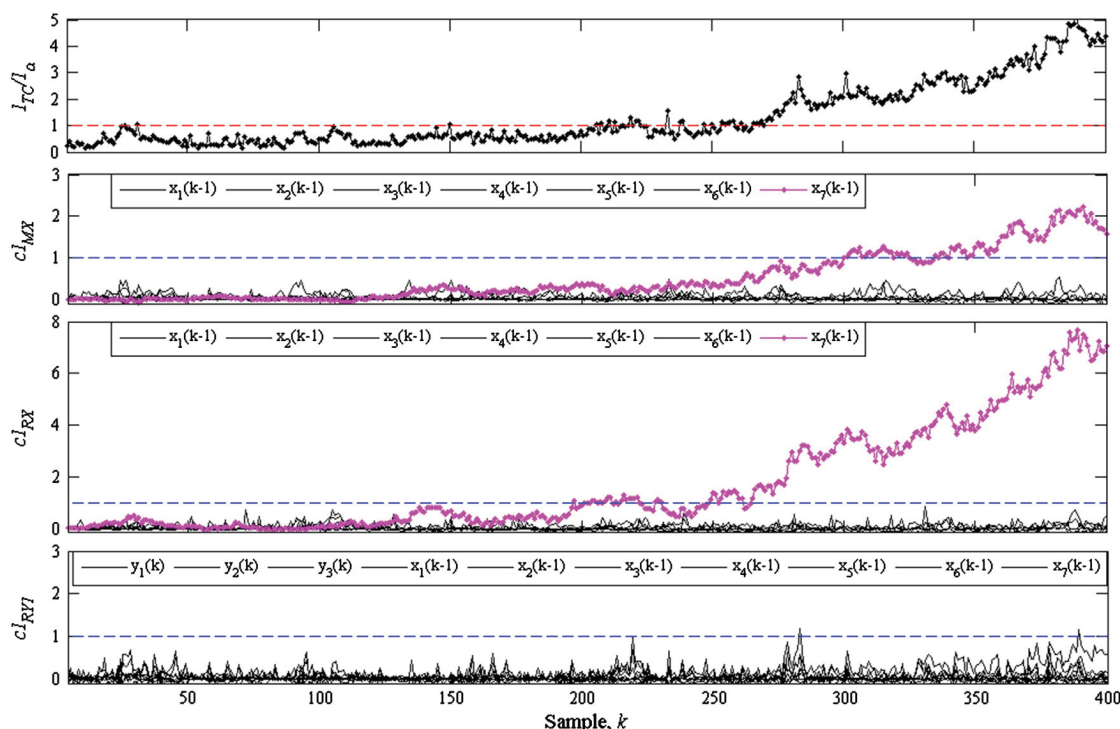


Fig. 8. Simulation of fault F.4): disturbance in T_0 . At $k > 200$, the contributions to the statistic I_{RX} identify a correlation loss of the variable x_7 ($=F_C$) followed by a change in its operating point (as identified in I_{MX} from $k = 300$ onwards).

684 magnitude of I_{MX} would be overweighed, and therefore the information
685 contained in the remaining three statistics will be partially hidden.

686 In the application examples, only small deviations with respect to
687 the nominal values were adopted, in order to evaluate the ability of the
688 control volume associated to I_{TC} for detecting the simulated errors.
689 When an anomaly was present in the process, the combination of the alerts
690 observed in the isolated statistics conforming I_{TC} was efficiently used
691 for classifying the perturbation source. Such preliminary diagnostic
692 was then completed through the analysis of contributions to the alarmed
693 statistics. Isolation of the disturbed variables was feasible through a de-
694 composition of each component statistic in their contributions. The re-
695 sults obtained with two simulation examples show that the proposed
696 technique is effective and accurate enough to be exploited with more em-
697 phasis in the future.

698 In summary, the proposed technique exhibits the following
699 advantages: 1) it is an effective tool to simultaneously cope with
700 quality monitoring, detection, and diagnosis of process faults, and
701 isolation of multiple sensor faults; 2) it is based on a linear LV
702 model and its calibration is relatively simple because only requires
703 data taken from the process operating under normal conditions;
704 and 3) the detection and diagnosis method is mainly based on the
705 theoretical considerations exposed in the first part of this work and
706 compiled in Table 2; instead of being based on recorded patterns of
707 historical faults, such as in the fault signature methods. A limitation
708 of the proposed technique is that it might not be advisable when
709 the data collected under normal operating conditions are multimodal
710 and/or when strong nonlinear correlations are present. However,
711 it could be extended to dynamic models (e.g., by using dynamic
712 PLS), and also to nonlinear models (e.g., by using kernel PLS).

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717 **Appendix A. Proofs of Lemma 1 and Theorems 1 and 2**

719 **Proof 1.** The oblique projector onto $Span\{\mathbf{A}\}$ along $Span\{\mathbf{B}\}$ can be
720 obtained through the following equation [27]:

$$\Pi_{\mathbf{A}|\mathbf{B}} = \mathbf{A}(\mathbf{A}'\Pi_{\mathbf{B}}^{\perp}\mathbf{A})^{-1}\mathbf{A}'\Pi_{\mathbf{B}}^{\perp} \quad (\text{A.1})$$

722 where $\Pi_{\mathbf{B}}^{\perp}$ is the orthogonal projector onto $Span\{\mathbf{B}\}^{\perp}$.

723 Since \mathbf{R} and \mathbf{S} are full column rank, then:

$$\Pi_{\mathbf{R}^{\perp}} = \Pi_{\mathbf{R}} = \mathbf{R}(\mathbf{R}'\mathbf{R})^{-1}\mathbf{R}', \quad (\text{A.2})$$

$$\Pi_{\mathbf{S}^{\perp}} = \Pi_{\mathbf{S}} = \mathbf{S}(\mathbf{S}'\mathbf{S})^{-1}\mathbf{S}'. \quad (\text{A.3})$$

726 Since $\mathbf{P}'\mathbf{R} = \mathbf{R}'\mathbf{P} = \mathbf{I}$ (or $\mathbf{Q}'\mathbf{S} = \mathbf{S}'\mathbf{Q} = \mathbf{I}$), then substituting Eq. (A.2)
728 [or Eq. (A.3)] into Eq. (A.1) yield: $\Pi_{\mathbf{P}'\mathbf{R}^{\perp}} = \mathbf{P}'\mathbf{R}'$ (or $\Pi_{\mathbf{Q}'\mathbf{S}^{\perp}} = \mathbf{Q}'\mathbf{S}'$). Similarly,
729 we have $\Pi_{\mathbf{R}^{\perp}\mathbf{P}} = \mathbf{I} - \mathbf{P}'\mathbf{R}'$ (or $\Pi_{\mathbf{S}^{\perp}\mathbf{Q}} = \mathbf{I} - \mathbf{Q}'\mathbf{S}'$). □
730

731 Partially, Lemma 1 has also been proved by Gang et al. [25].

732 **Proof 2.** Equations (10, 11) can be proved by taking into account
733 that: (i) $Span\{\mathbf{I} - \mathbf{P}'\mathbf{R}'\} = Span\{\mathbf{R}\}^{\perp}$ and $Span\{\mathbf{I} - \mathbf{Q}'\mathbf{S}'\} = Span\{\mathbf{S}\}^{\perp}$
734 (see Lemma 1); and (ii) the projections belong to complementary
735 subspaces, because $rank(\mathbf{P}'(\mathbf{I} - \mathbf{P}'\mathbf{R}')) = \dim(S_{MX}) + \dim(S_{RX}) = m$
736 and $rank(\mathbf{Q}'(\mathbf{I} - \mathbf{Q}'\mathbf{S}')) = \dim(S_{MY}) + \dim(S_{RY}) = p$. Eq. (12) is direct-
737 ly derived from Eq. (7). □

738 **Proof 3.** Substituting $\hat{\mathbf{y}} = \mathbf{Q}\hat{\mathbf{u}}$ into Eq. (21b), one obtains $D_{\hat{\mathbf{y}}} = \hat{\mathbf{u}}'\mathbf{Q}'$
739 $(\mathbf{Q}\mathbf{A}\mathbf{Q}')^{-1}\mathbf{Q}\hat{\mathbf{u}}$. The singular value decomposition of the (full-column
740 rank) matrix \mathbf{Q} ($p \times A$) is $\mathbf{Q} = \mathbf{V}[\Sigma \mathbf{0}]\mathbf{W}'$, where Σ ($A \times A$) is a non-
741 singular diagonal matrix, and \mathbf{W} ($p \times p$) and \mathbf{V} ($A \times A$) are orthonormal
742 matrices. Then,

$$\mathbf{Q}'(\mathbf{Q}\mathbf{A}\mathbf{Q}')^{-1}\mathbf{Q} = \mathbf{V}[\Sigma \mathbf{0}]\mathbf{W}'\left(\mathbf{W}\begin{bmatrix} \Sigma \\ \mathbf{0} \end{bmatrix}\mathbf{V}'\mathbf{A}\mathbf{V}[\Sigma \mathbf{0}]\mathbf{W}'\right)^{-1}\mathbf{W}\begin{bmatrix} \Sigma \\ \mathbf{0} \end{bmatrix}\mathbf{V}', \quad (\text{A.4})$$

$$= \mathbf{V}\Sigma(\Sigma\mathbf{V}'\mathbf{A}\mathbf{V}\Sigma)^{-1}\Sigma\mathbf{V}' = \Delta^{-1}. \quad 744$$

Therefore, $D_{\hat{\mathbf{y}}} = \hat{\mathbf{u}}' \mathbf{\Lambda}^{-1} \hat{\mathbf{u}} = T_{\mathbf{u}}^2$. By combining Eqs. (18) and (15b) with $\hat{\mathbf{u}} = \mathbf{BtS}$, we obtain $T_{\mathbf{u}}^2 = \mathbf{t}' \mathbf{B} (\mathbf{B}^{-1} \mathbf{\Lambda}^{-1} \mathbf{B}^{-1}) \mathbf{Bt} = T_{\mathbf{t}}^2$. By replacing $\hat{\mathbf{x}} = \mathbf{Pt}$ into Eq. (21a): $D_{\hat{\mathbf{x}}} = \mathbf{t}' \mathbf{P}' (\mathbf{PAP}')^{-1} \mathbf{Pt}$. Similarly to the derivation of Eq. (A.4), it is obtained: $\mathbf{P}' (\mathbf{PAP}')^{-1} \mathbf{P} = \mathbf{\Lambda}^{-1}$; hence $D_{\hat{\mathbf{x}}} = \mathbf{t}' \mathbf{\Lambda}^{-1} \mathbf{t} = T_{\mathbf{t}}^2$. From all these equalities, Theorem 2 is proven. \square

Appendix B. Control limits

To calculate the confidence limits we assume that \mathbf{x} and \mathbf{y} approximately follow multivariate normal behaviors. The T^2 control limit at the α significance level is given by [5] $\tau_{\alpha}^2 = [(AN^2 - A)/(N^2 + NA)] F_{A, N-A}(\alpha)$, where $F_{A, N-A}(\cdot)$ is the F -distribution with A and $N-A$ degrees of freedom. On the other hand, the α -control limit of $SPE_{\mathbf{x}}$ is given by [7] $\delta_{\mathbf{x}, \alpha}^2 = (\sigma^2/2\nu) \chi_{2\nu^2/\sigma^2}^2(\alpha)$ where ν and σ^2 are the sample average and variance estimated with N observations of $SPE_{\mathbf{x}}$, and $\chi_{2\nu^2/\sigma^2}^2(\cdot)$ is the χ^2 -distribution with $2\nu^2/\sigma^2$ degrees of freedom. Similarly, the control limits of $SPE_{\mathbf{y}_1}$ and $SPE_{\mathbf{y}_2}$ are calculated.

The 100(1- α)% control limit of the I_{TC} is given by [11]

$$I_{\alpha} = g \chi_h^2(\alpha) \quad (\text{B.1})$$

with g and h given by:

$$g = \frac{\text{tr} \left[\left(\mathbf{R}_{[\mathbf{y}' \mathbf{x}']} \Phi \right)^2 \right]}{\text{tr} \left(\mathbf{R}_{[\mathbf{y}' \mathbf{x}']} \Phi \right)}, \quad h = \frac{\left[\text{tr} \left(\mathbf{R}_{[\mathbf{y}' \mathbf{x}']} \Phi \right) \right]^2}{\text{tr} \left[\left(\mathbf{R}_{[\mathbf{y}' \mathbf{x}']} \Phi \right)^2 \right]} \quad (\text{B.2})$$

where $\mathbf{R}_{[\mathbf{y}' \mathbf{x}]}$ is the correlation matrix of the extended vector $[\mathbf{y}' \mathbf{x}]'$ and Φ is equal to

$$\Phi = \begin{bmatrix} \mathbf{SQ}' \mathbf{QS}' / \delta_{\mathbf{y}_1, \alpha}^2 + (\mathbf{I} - \mathbf{QS}')' (\mathbf{I} - \mathbf{QS}') / \delta_{\mathbf{y}_2, \alpha}^2 & -\mathbf{SQ}' \mathbf{QBR}' / \delta_{\mathbf{y}_1, \alpha}^2 \\ -\mathbf{RBQ}' \mathbf{QS}' / \delta_{\mathbf{y}_1, \alpha}^2 & \Phi_{22} \end{bmatrix}, \quad \Phi_{22} = \mathbf{R}\mathbf{\Lambda}^{-1} \mathbf{R}' / \tau_{\alpha}^2 + (\mathbf{I} - \mathbf{PR}')' (\mathbf{I} - \mathbf{PR}') / \delta_{\mathbf{x}, \alpha}^2 + \mathbf{RBQ}' \mathbf{QBR}' / \delta_{\mathbf{y}_1, \alpha}^2 \quad (\text{B.3})$$

In all cases, the control limits were set at the 99 percentile ($\alpha = 0.01$).

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